



Patent
Attorney's Docket No. 1015290-000500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. Y. LI et al.

Application No.: 09/820,695

Filed: March 30, 2001

For: METHOD OF PLASMA ETCHING
LOW-K DIELECTRIC MATERIALS

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) Group Art Unit: 1763

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) Examiner: A. W. Olsen

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) Confirmation No.: 4162

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a response to the Official Action dated February 23, 2006. Please
amend the above-identified application as follows:

Entered with RCE 5/23/6
MW 5/26/6